



## Actuators in Microelectromechanical Systems (MEMS)

Guest Editor:

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### Message from the Guest Editor

Dear Colleagues,

This Special Issue will present a collection of recent advancements in the field of microelectromechanical systems (MEMS) actuators. Just as the spread of MEMS sensors in the consumer world triggered a revolution of user interfaces in gaming, mobile phones, and navigation, new generations of actuators will dramatically impact our lives and will enable the evolution of the Internet of Things in its different declinations. Devices such as piezoelectric ultrasound transducers for range finding, echography and printing applications, loudspeakers for an improved audio reproduction fidelity and micromirrors enabling picoprojection, augmented reality and autonomous driving are hastily pervading our society.

Prof. Dr. Attilio Frangi  
*Guest Editor*

